INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Multiple sheets used when necessary)

SHEET 1 OF 1

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 First Named Inventor
 Takada et al.

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 Examiner
 Piery, Michael

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U.S. PATENT DOCUMENTS

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	Examiner Initials	Cite No.	Document Number Number - Kind Code (If known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear

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NON PATENT LITERATURE DOCUMENTS			
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	1	CRIVELLO, JAMES V. Possibilities for Photoimaging Using Onium Salts, <i>Polymer Engineering and Science</i> , Mid-December, Vol. 23, No. 17, pages 953-956, 1983.	
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Examiner Signature

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